

Bulletin I0140J 09/00

# IR207DM16CCB

#### STANDARD RECOVERY DIODES

■ Junction Size: Rectangular 207 x 157 mils

■ Wafer Size: 4"

■ V<sub>RRM</sub> Class: 1600 V

■ Passivation Process: Glassivated MOAT

■ Reference IR Packaged Part: 20ETS Series

### Major Ratings and Characteristics

Parameters	Units	<b>Test Conditions</b>
V <sub>FM</sub> Maximum Forward Voltage	1.15 V	$T_J = 25^{\circ}C, I_F = 20 A$
V <sub>RRM</sub> Reverse Breakdown Voltage	1600 V (**)	$T_J = 25^{\circ}\text{C}, I_{RRM} = 100 \mu\text{A}$ (*)

<sup>(\*)</sup> Nitrogen flow on die edge.

### Mechanical Characteristics

Nominal Back Metal Composition, Thickness	Cr-Ni-Ag (1 KA-4 KA-6 KA)
Nominal Front Metal Composition, Thickness	100% AI, (20 µm)
Chip Dimensions	207 x 157 mils (see drawing)
Wafer Diameter	100 mm, with std. < 110 > flat
WaferThickness	330 μm, ± 10 μm
Maximum Width of Sawing Line	45 µm
Reject Ink Dot Size	0.25 mm diameter minimum
Ink Dot Location	See drawing
Recommended Storage Environment	Storage in original container, in dessicated nitrogen, with no contamination

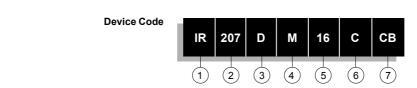
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<sup>(\*\*)</sup> Wafer and die Probe test clamped at 1200V to limit arcing. 1600V BV testable only in encapsulated packages

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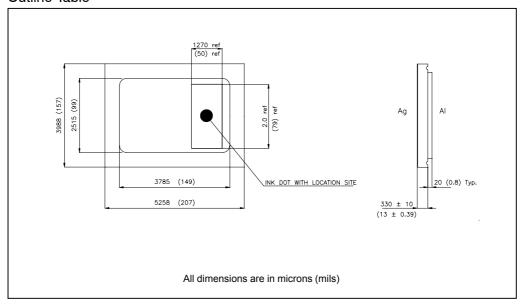
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### Ordering Information Table



- International Rectifier Device
- 2 Chip Dimension in Mils
- 3 Type of Device: D = Wire Bondable Standard Recovery Diode
- Passivation Process: M = Glassivated MOAT
- 5 Voltage code: Code x 100 = V<sub>RRM</sub>
- 6 Metallization: C = Aluminium (Anode) Silver (Cathode)
- CB = Probed Uncut Die (wafer in box)None = Probed Die in chip carrier

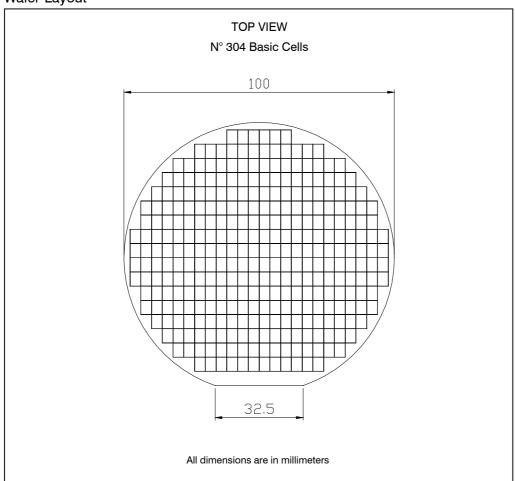
### **Outline Table**



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### Wafer Layout



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